



THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of)
James E. Moon et al.)
Patent Application No.: 10/003,851)
Filed: November 2, 2001)
For: METHOD FOR FABRICATING MEMS)
AND MICROFLUIDIC DEVICES USING)
SMILE, LATENT MASKING, AND)
DELAYED LOCOS TECHNIQUES)

Art Unit: 1763

Examiner: Allan W. Olsen

AMENDMENT AND RESPONSE

OK to file 8/13/2004
Commissioner for Patents
PO Box 1450
Alexandria, VA 22313-1450

Sir:

The following amendments and remarks are submitted in response to the Office Action of April 30, 2004 in the above-identified patent application.